

# A Coded Aperture Magnetic Sector Mass Spectrometer

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# Motivation: Miniaturizing a Mass Spectrometer



- Goals
  - Reduce size, cost, and power consumption in mass spectrometry by two orders of magnitude
- Applications
  - Space: Mars and lunar rover
  - Medical: Analyze blood chemistry
  - Military/Security: Chemical/biological hazard alert
  - Environmental: Sense pollutants

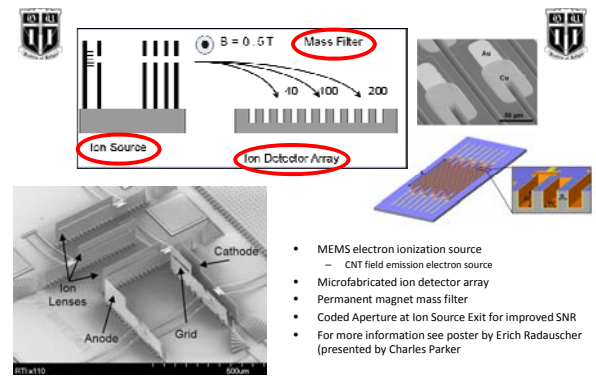
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# CAMMS System Components



- MEMS electron ionization source
  - CNT field emission electron source
- Microfabricated ion detector array
- Permanent magnet mass filter
- Coded Aperture at Ion Source Exit for improved SNR
- For more information see poster by Erich Radauscher (presented by Charles Parker)

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# Coded Aperture Motivation and Presentation Outline



- Miniaturized systems suffer from reduced signal intensity
  - [E.R. Badman, R.G. Cooks, Anal. Chem. 72 (2000) 3291.]
- Aperture Coding has been used in Optical Spectroscopy to dramatically boost Signal to Noise Ratios
  - [David J. Brady, Optical Imaging and Spectroscopy Wiley-OSA, 2009]
  - [M. Gehm, S. McCain, N. Pitsianis, D. Brady, P. Potluri, and M. Sullivan, "Static two-dimensional aperture coding for multimodal, multiplex spectroscopy," Appl. Opt. 45, 2965-2974 (2006).]
- Presentation Outline
  - Aperture Coding in Optical Spectroscopy
  - Aperture Coding in Mass Spectroscopy and Ion Optics
  - Poof of Concept Test Bed Design and Component Focus
  - Experimental Results Showing 15x Intensity Improvement
  - Summary, Conclusions, and Future Work

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**Aperture Coding in Light Optics**

Small Slit      Large Slit      Coded Aperture

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**Aperture Coding in Light Optics**

Binned CCD Data (2N Rows) → Row Subtracted Data (N Rows) → Inverted Data (N Estimates) → Average Spectrum of N Estimates

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**Aperture Coding in Light Optics**

Spectral Density (A.U.) vs. Wavelength (nm)

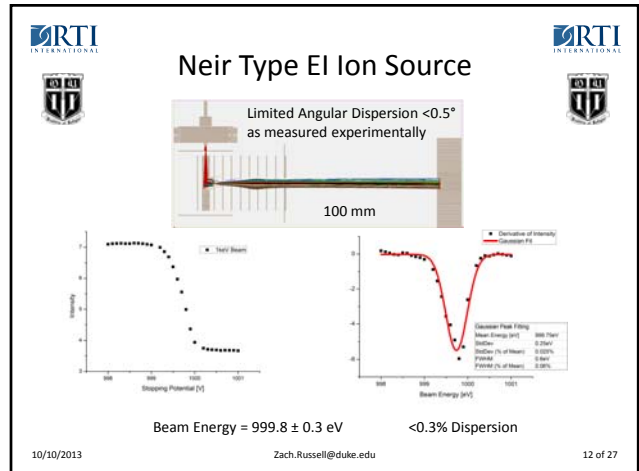
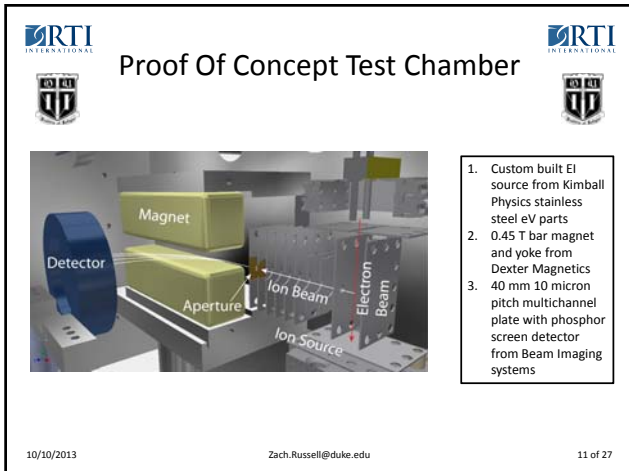
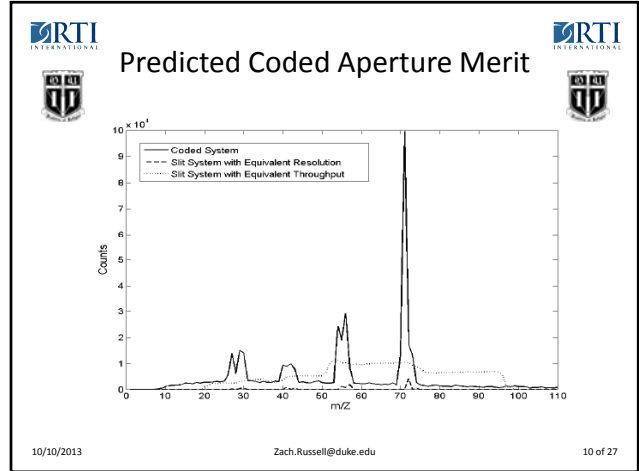
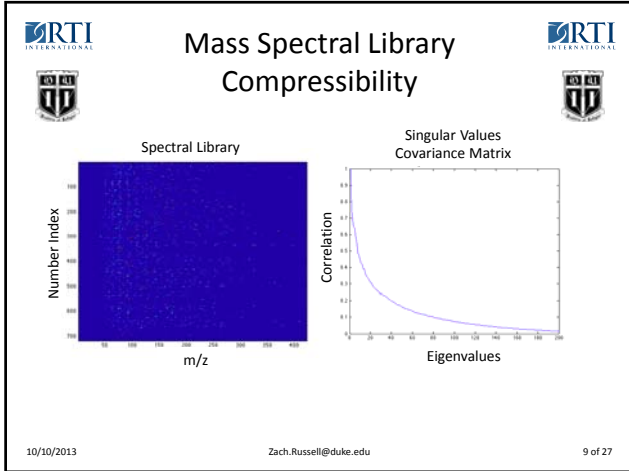
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**Coding Magnetic Sector Instruments**

Analyte Introduction, Ionization Chamber, Acceleration Grids, Ions Paths, Coded Aperture Array, Volume of Ion Trajectories, Faraday Cup Detector Array

[1] C.B. Parker, D.J. Brady, J.T. Glass, and M.E. Gehm, Coded mass spectroscopy, US Patent 7,399,957 (2008).

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**Hadamard Coded Apertures**

Single Slit

2D Hadamard Arrays

8 12 16

1D Hadamard Slit Arrays

8 12 16 24 32

Transmittance (%)

Circular Aperture Diameter (micrometers)

Hadamard patterns were chosen due to their ease in incorporation into the forward model

The apertures were fabricated via deep reactive ion etching (DRIE) of 250 micron thick silicon wafers with feature sizes down to 25 microns

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**Aperture Fabrication-1**

Stainless steel test aperture - laser milled

3mm

- 50  $\mu\text{m}$  features intended to be squares (~50  $\mu\text{m}$  LASER diameter)
- Minimal feature sizes recommended for this same material photo (1micron)

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**Aperture Fabrication**

Carrier Wafer

Si

Resist

Etched Aperture Patterns

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**Aperture Fabrication**

Thru holes and slits as small as 10 $\mu\text{m}$  (minimum feature size) were fabricated in this way.

← 20 microns

← 10 microns

Magnification Accelerating Voltage Working Distance Detector  
44x 30 kV 23 mm SE 1 mm

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### Aperture Fabrication

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### Experimental Raw Data

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### How Coding Works

Raw Data = Forward Matrix X Mass Spectrum + Noise

- The inverse of the Forward Matrix allows transformation of the raw data into the mass spectrum.
- The Forward Matrix is derived from the physics of the system and geometry of the coded aperture
- For additional information see poster by Evan Chen (presented by Zach Russell)

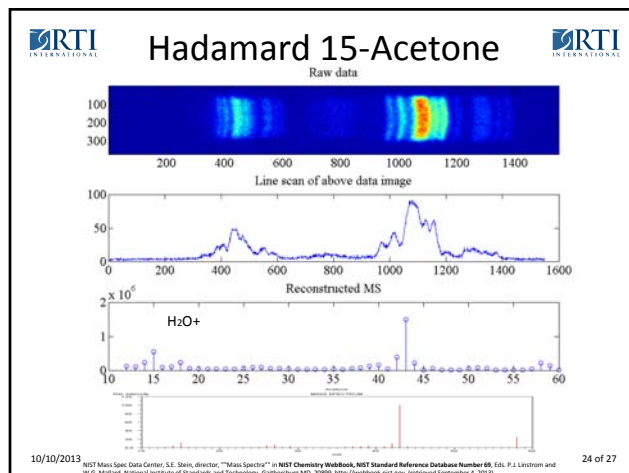
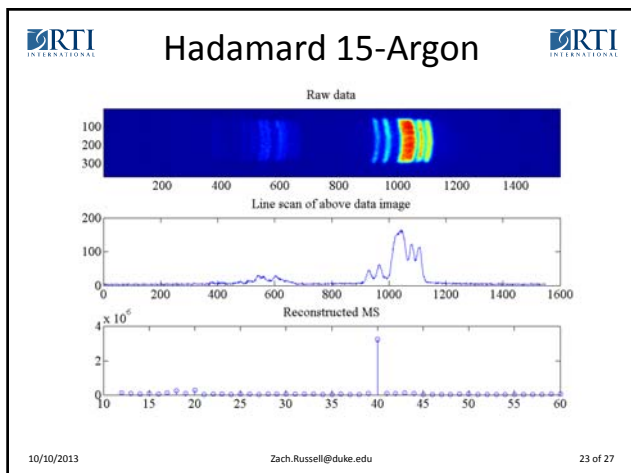
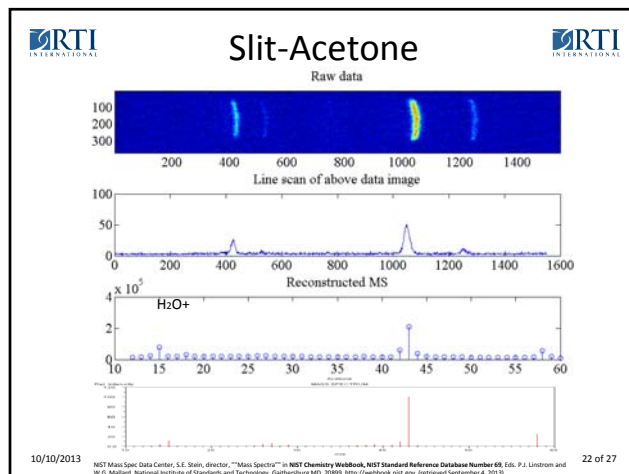
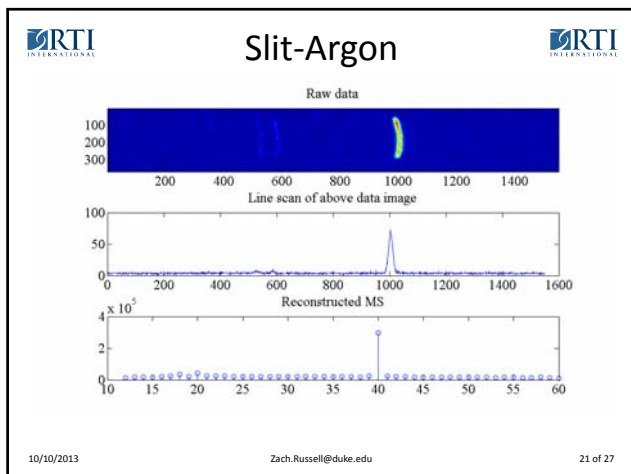
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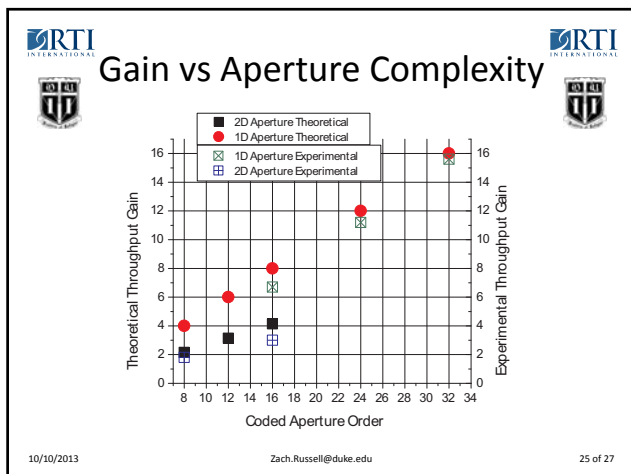
### Coded Aperture 15x Gain

Traditional Magnetic Sector Mass Spectrometry with a Single Slit

Magnetic Sector Mass Spectrometry with a Coded Aperture showing a 15x signal gain

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### Future Work

#### Micro Component Integration

**Mattauch Herzog Geometry**

**Cycloid Geometry**

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## Thank You! Questions?

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NIST Mass Spec Data Center, S.E. Stein, director, "Mass Spectra" in NIST Chemistry WebBook, NIST Standard Reference Database Number 69, Eds. P.J. Linstrom and W.G. Mallard, National Institute of Standards and Technology, Gaithersburg MD, 20899, <http://webbook.nist.gov>, (retrieved September 4, 2013).

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## Abstract (for reference only)

- The ultimate goal of this project is to develop a coded aperture microfabricated mass spectrometer (CAMMS) [1]. This instrument concept is based on integrating aperture coding [2], used primarily in optical spectroscopy, with a carbon nanotube-based field emission source, charged particle optics on a microfabricated MEMS (MicroElectroMechanical Systems) platform and a permanent magnet magnetic sector. MEMS technology has been shown to be an excellent platform for the development of miniaturized charged particle devices [3]. However, decreased throughput and small sample sizes in microfabricated instruments are expected to lead to diminished performance. To minimize this degradation in performance we are investigating the principles of multi-aperture coding [1]. Use of coded apertures can eliminate the historical trade-off between resolution and signal intensity in a mass spectrometer. Our current focus is proof of concept work on the application of coded apertures to ion optics in a testbed with a traditional thermal electron ionization ion source. The charged particle simulation program SIMION is utilized to inform system design as well as to establish appropriate working conditions for electrostatic lens systems. This presentation will include: (i) the microfabricated system concept, (ii) the coded aperture-testbed design and optimization, and (iii) results from Hadamard coded apertures that have been shown to provide a 15x increase in throughput as compared to single slits without sacrificing mass resolution.

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